

Docket No.: 070759-0033

PATENT

Reply Under 37 CFR 1.116 - Expedited Procedure - Technology Center 2800

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Masashi WATANABE, et al.

Application No.: 10/531,391

Customer No.: 20277

Filed: April 15, 2005

Confirmation No.: 6874

Group Art Unit: 2828

Examiner: Xinning Niu

Title: SEMICONDUCTOR LASER DEVICE

RESPONSE UNDER 37 CFR § 1.116

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Commissioner for Patents
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Sir:

Reconsideration of the rejection imposed in the Office Action dated June 5, 2009, is solicited in light of the following Remarks.

Remarks begin on page 2 of this paper.